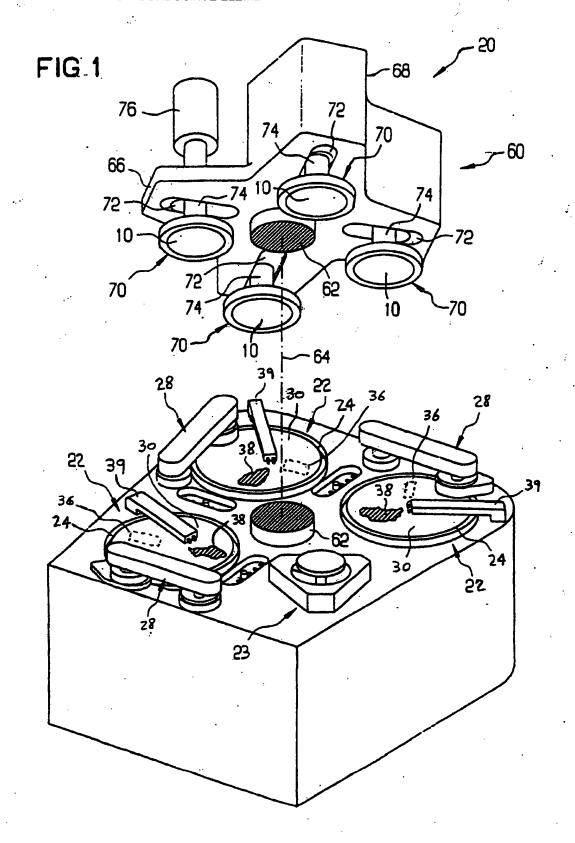
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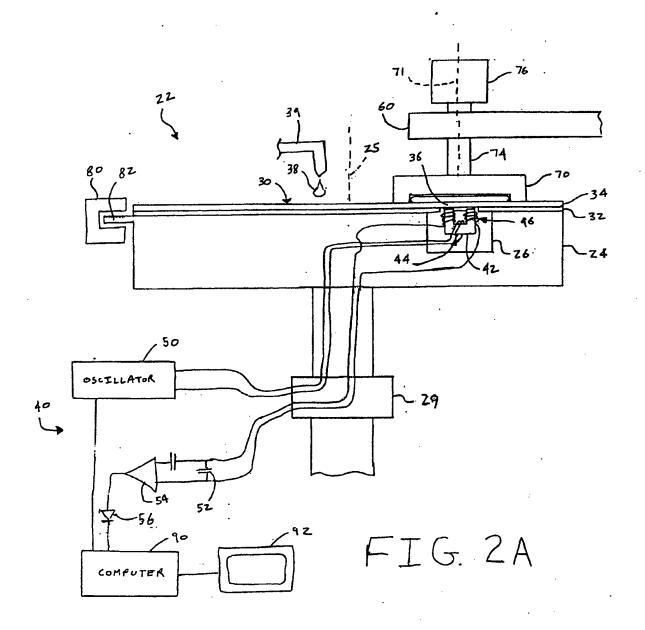
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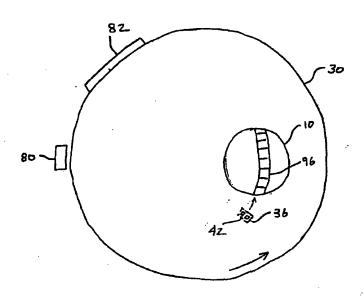
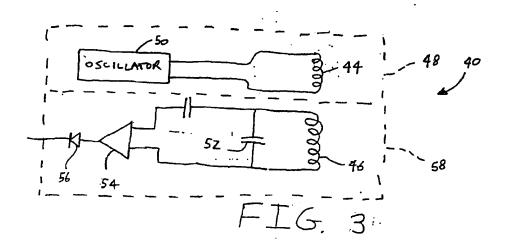
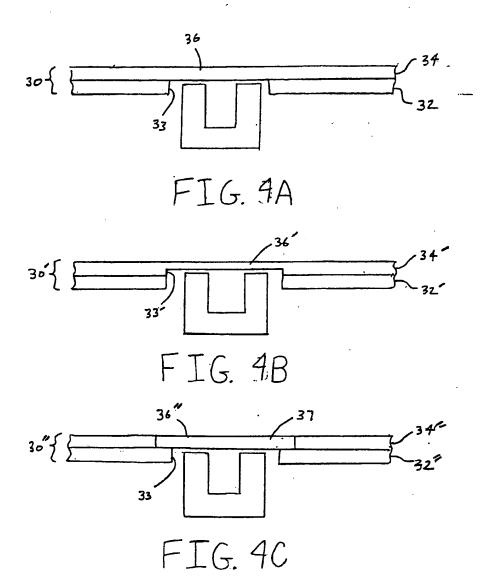


FIG. 2B



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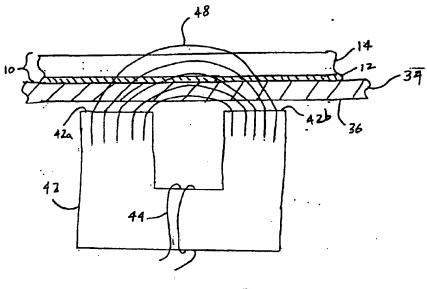


FIG. 5

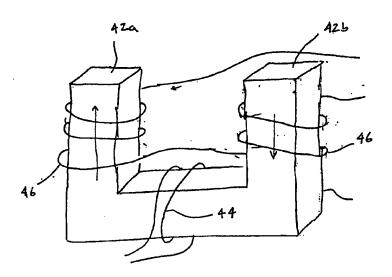
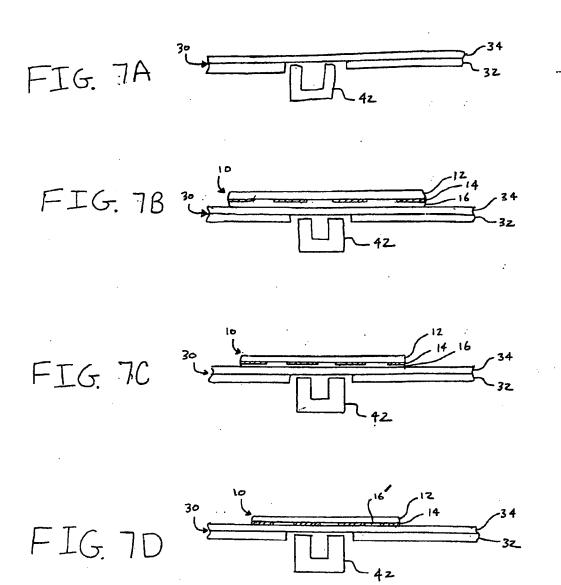


FIG. 6

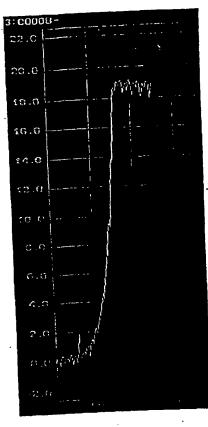
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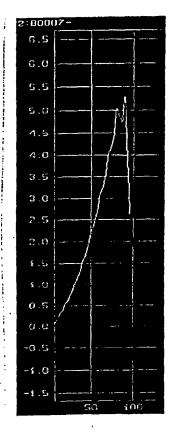


FIG. 8

FIG. 11

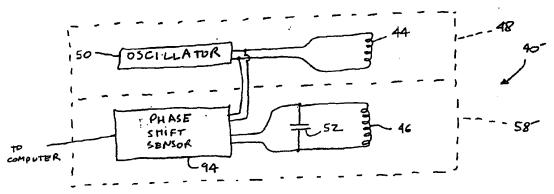
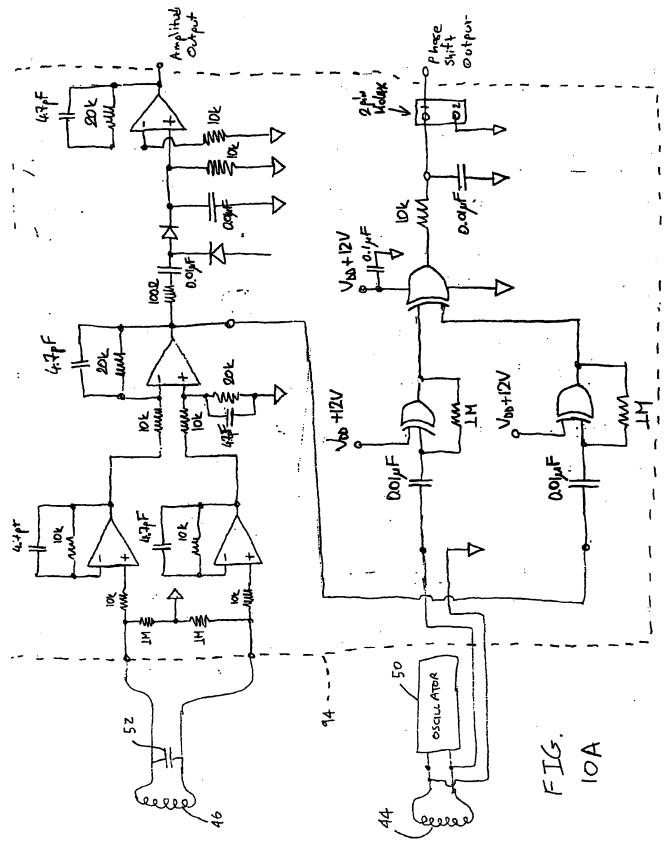


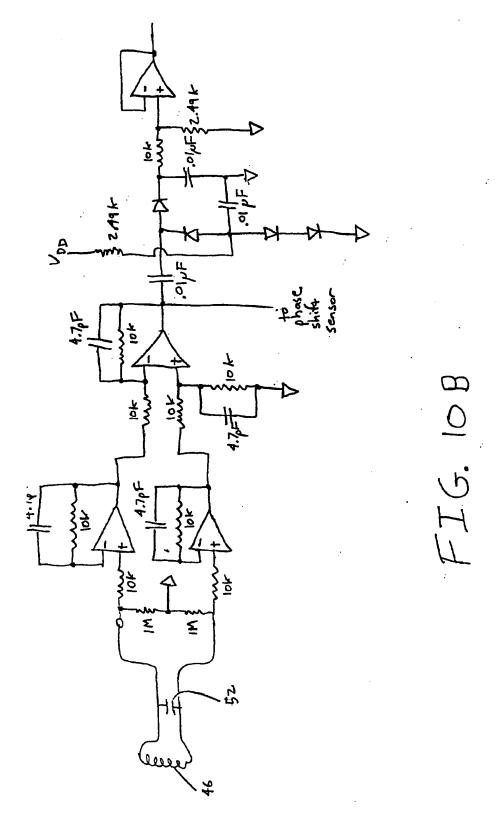
FIG. 9

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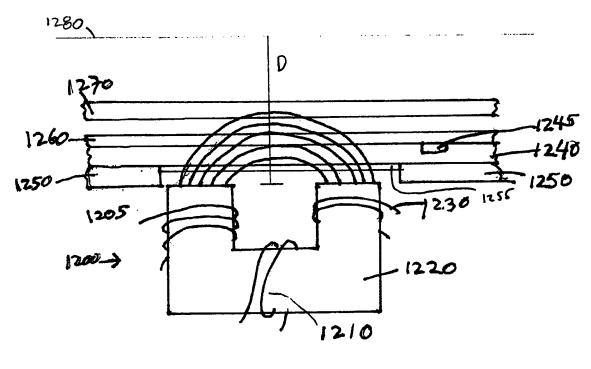
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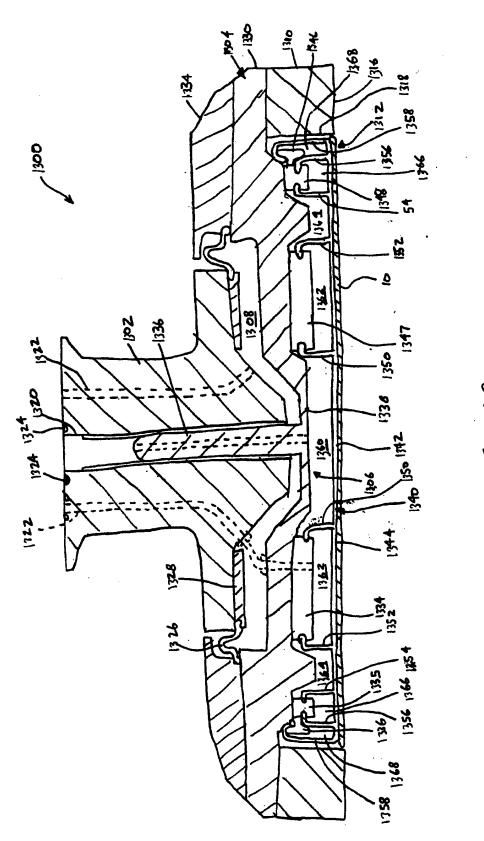
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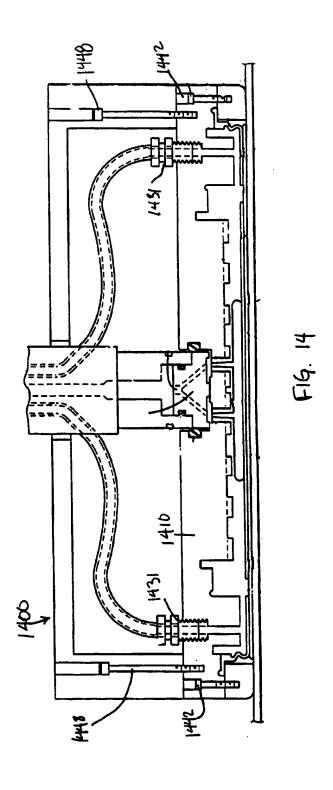
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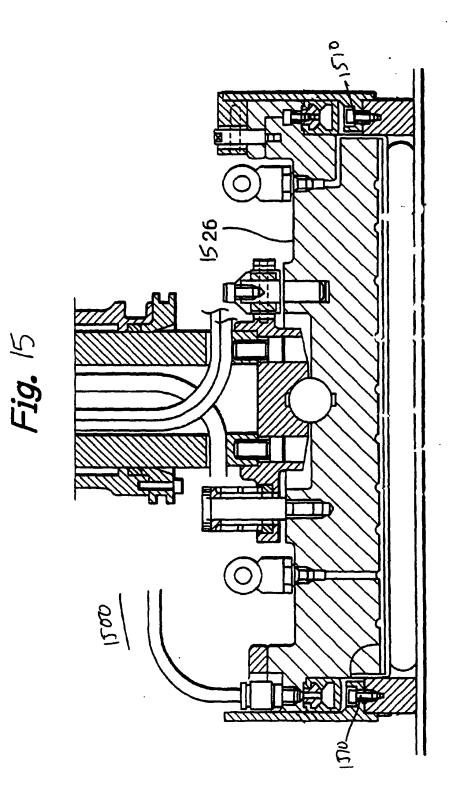
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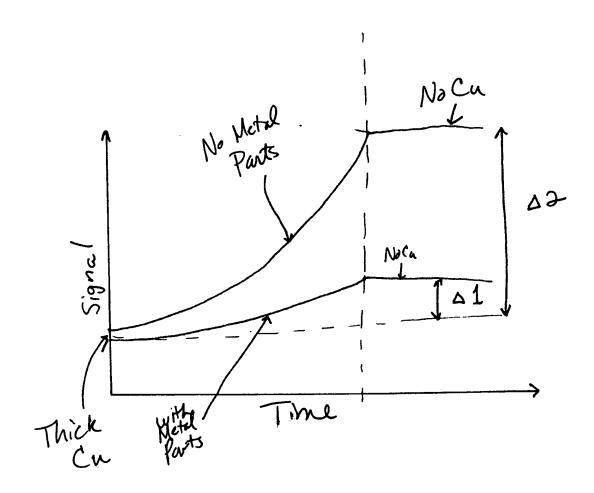


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